



PATENT

Docket No. 1232-4807

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s): Tsuneo KANDA

Group Art Unit: 2851

Serial No. : 10/033,081

Examiner: A. Mathews

Filed : December 27, 2001

For : MASK AND PROJECTION EXPOSURE APPARATUS

STATEMENT OF THE SUBSTANCE OF INTERVIEW

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Applicants respectfully submit the following summary regarding the interview conducted between Examiner Alan A. Mathews and the undersigned on November 1, 2004.

INTERVIEW SUMMARY

On November 1, 2004, Examiner Mathews held discussions with the undersigned regarding claims 1-16 and 38. The Examiner informed the undersigned that in order to place the application in condition for allowance, Examiner suggested removal of duplicate language in claim 38 and cancellation of withdrawn claims 1-16 through an Examiner's Amendment. The undersigned agreed and authorized the proposed Examiner's Amendment.

This Statement is timely filed to reply to the Interview Summary. No fee is due by filing of this paper. However, the Commissioner is hereby authorized to charge any fees which may be required for this filing to Deposit Account No. 13-4500, Order No. 1232-4807.

Respectfully submitted,
MORGAN & FINNEGAN, LLP

Dated: 11/12/04

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